

CV of Presenter

	Name:	Sumio <u>Hosaka</u>
Job Title:	Professor	
Organization:	Graduate school of Engineering, Gunma University	
Major Field:	Nano devices, Nano fabrication, Nano metrology	
Education:	1971 Graduated in Electric Engineering from Yamanashi University 1983 Received Ph. D. degree in Engineering from Waseda University	
Job history:	1971 Hitachi Central Research Lab. (HCRL), Co. Ltd. Kokubunji, Tokyo working on semiconductor lithography using electron, ion and optical beams, nano-metrology using electron beam and scanning probe microscopy (SPM), in HCRL and terabyte huge storage using SPM in the Hitachi Advanced Research Lab. (HARL). 2000 Hitachi Kenki Co., Tsuchiura, Ibaraki working on development of in-line atomic force microscope as an AFM design manager 2001 Department of Electronic engineering, Gunma University, Kiryu, Gunma, Professor 2003 Graduate school of Engineering, Gunma University, Kiryu, Gunma, Professor working on nano devices, nano fabrication, and nano metrology	